

AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Haupt	Docket No.:	QIM 2003 P 51718 US
Serial No.:	10/766,053	Art Unit:	2892
Filed:	January 28, 2004	Examiner:	Thanh Y. Tran
For:	Method for N+ Doping of Amorphous Silicon and Polysilicon Electrodes in Deep Trenches		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.116

Dear Sir:

Applicant respectfully submits the following amendments and remarks in response to Examiner's Office Action dated March 20, 2008, which Action is made final. Applicant respectfully requests that these amendments and remarks be entered in pursuant to the provisions of 37 C.F.R. § 1.116, and respectfully requests reconsideration of claims 1-28.